

EV633201681

Inventor: **Wei Guo et al.**

Title: **High Purity Nickel/Vanadium Sputtering Components**

Assignee: **Honeywell International Inc.**

Serial No.: **10/720,231**

Filed: **November 25, 2003 [RCE Filed Herewith]**

Client Ref.: **HO004345**

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether the listed references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

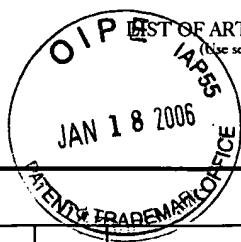
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By: _____

David G. Latwesen
David G. Latwesen, Ph.D.
Reg. No. 38,533
Wells St. John P.S.

Form PTO-1449

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10/720,231BEST OF ART CITED BY APPLICANT
(Use several sheets if necessary)APPLICANT
Wei Guo et al.FILING DATE
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1742

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	2,876,180	03/59	Burwell Jr. et al.			
	AB	3,294,481	12/66	Burwell			
	AC	3,320,024	05/67	Burwell			
	AD	4,610,720	09/86	Schmidt et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL	US03/ 37463	11/03	PCT Search Report				
	AM							
	AN							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AO		
	AP		
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.